

INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (PTO-1449)				ATTY. DOCKET NO. 006217 USA/Consilium/Consilium	SERIAL NO. 09/927,444
APPLICANT Nicholas A. WARD et al.					
FILING DATE August 13, 2001					
U.S. PATENT DOCUMENTS					
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS
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	6,245,581 B1	06/12/01	Bonser et al.		04/19/00
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RECEIVED 7/29/04					
EXAMINER			DATE CONSIDERED		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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(PTO-1449)		APPLICANT Nicholas A. WARD et al.					
		FILING DATE August 13, 2001		GROUP 2125			
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
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EXAMINER <i>R. H.</i>		DATE CONSIDERED <i>7/29/04</i>					

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